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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

OSAWA, Atsushi

Date: April 24, 2006

Serial No.:

10/785,685

Group Art Unit: 1761

Date Filed:

February 23, 2004

For:

SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **STATUS INQUIRY LETTER**

Sir:

We filed the above application with the U. S. Patent and Trademark Office on February 23, 2004.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Attorney: James A. Finder

Respectfully/Submitted,

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